

Electronic Patent Application Fee Transmittal

Application Number:	09864309			
Filing Date:	25-May-2001			
Title of Invention:	Exposure apparatus, coating/developing system, device manufacturing system, device manufacturing method, semiconductor manufacturing factory, and exposure apparatus maintenance method			
First Named Inventor:	Shigeyuki Uzawa			
Filer:	Lawrence A. Stahl/Laura Petty			
Attorney Docket Number:	862.C2239			
Filed as Large Entity				
Utility	Filing Fees			
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				790